

31765

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
50060-00040

In Re Application Of: SNIEGOWSKI ET AL

O I P E  
AUG 22 2002  
PATENT TRADEMARK OFFICE

|                          |                        |                     |                        |
|--------------------------|------------------------|---------------------|------------------------|
| Serial No.<br>09/840,716 | Filing Date<br>4/23/01 | Examiner<br>UNKNOWN | Group Art Unit<br>1765 |
|--------------------------|------------------------|---------------------|------------------------|

Title: METHOD FOR MAKING A MICROSTRUCTURE BY SURFACE MICROMACHINING

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37 CFR 1.97(b)

1.  The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last.

37 CFR 1.97(c)

2.  The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either:

1. a Final Action under 37 CFR 1.113, or
2. a Notice of Allowance under 37 CFR 1.311,

whichever occurs first.

Also submitted herewith is:

a certification as specified in 37 CFR 1.97(e);

OR

the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).

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